

Application No.	Applicant(s)
10/005,435	YAMAZAKI ET AL.
Examiner	Art Unit
Mike Oi	2871

SEARCHED					
Class	Subclass	Date	Examiner		
349	113	3/22/2004	ZQQ		
349	114	3/22/2004	ZQQ		
349	137	3/22/2004	ZQQ		
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
349	113	3/23/2004	ZQQ		
349	114	3/23/2004	ZQQ		
349	137	3/23/2004	ZQQ		

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
East search	3/22/2004	zww
Patentability of claims consulted with Mr. Ken Parker	3/23/2004	ZQQ
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